

U.S.S.N. 10,656,986

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Lu et al.

Group Art Unit: 2813

Serial No.: 10,656,986

Examiner: Doty, H.A.

Filed: 09/04/2003

In Response to Office Action

Dated: 05/30/2006

For:

**MULTIPLE EXPOSURE METHOD FOR FORMING
PATTERNED PHOTORESIST LAYER**

Attorney Docket No.: 67,200-1145(2002-1332)

CERTIFICATE OF MAILING OR FACSIMILE TRANSMISSION

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Randy W. Tung

Printed Name

Please forward all correspondence to
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Signature8/29/06

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RESPONSE TO OFFICE ACTION

Assistant Commissioner
for Patents
P.O. Box 1450
Alexandria, Va 22313-1450

Dear Sir:

In response to an Office Action mailed 05/30/2006,
please enter the following amendments and consider the following
remarks.